


INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	Docket number (Optional) 15689.91	Application Number 09/998,599
	Applicant(s) Shinji Uebayashi, et al.	
	Filing Date 11/16/2001	Group Art Unit 2616

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

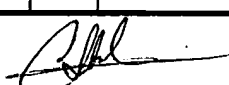
U.S. PATENT APPLICATION PUBLICATIONS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
Cgs ↓	1	08-265835	10/11/1996	Japan	H04Q7	36	x	
	2	09-083429	03/28/1997	Japan	H04B7	26	x	
	3	09-261761	10/03/1997	Japan	H04Q7	38	x	
	4	10-136429	05/22/1998	Japan	H04Q7	28	x	
	5	2000-092541	03/31/2000	Japan	H04Q7	22	x	
	6	2002-135847	05/10/2002	Japan	H04Q7	38	x	
	7	2002-159058	05/31/2002	Japan	H04Q7	38	x	
	8	WO00/42808	07/20/2000	PCT	H04Q7	38	x	

EXAMINER 	DATE CONSIDERED 1/4/07
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*Examiner Initial	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
CS	9	Official Notice of Rejection; Case No.: DCMH120310, Patent Application No.: 2000-351886
EXAMINER		
	DATE CONSIDERED 1/4/07	
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